

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/537,194	TAKASHIMA ET AL.	
Examiner	Art Unit	
John D. Chaoban	1702	

	SEAR	CHED	
Class	Subclass	Date	Examiner

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		

SEARCH NO (INCLUDING SEARCH	TES STRATEGY	)
	DATE	EXMR